

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	Docket No: Q85660
Heiji WATANABE, et al.	
Appln. No.: 10/521,311	Group Art Unit: 2815
Confirmation No.: 1690	Examiner: WARREN, MATTHEW E
Filed: January 14, 2005	
For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND MANUFACTURING APPARATUS OF THE SAME	

RESPONSE UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 2, 2007, please amend the above-identified application as follows on the accompanying pages.

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